

## Development of scalable Silicon quantum computer technology

#### Project manager

(selected in 2022)

# **TARUCHA** Seigo

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#### Leader's institution

RIKFN

#### R&D institutions

RIKEN The University of Osaka The University of Tokyo Kobe University AIST

#### Summary of the project

This project aims to develop scalable multi-qubit devices toward realization of Silicon quantum computer. We will use sparse integration and medium-distance quantum coupling to implement a unit structure of gubits and scale up the gubit system by integrating the unit structures. Based on this method we will develop technology bases appropriate to implement large-scale quantum computers by 2030, and expand them in cooperation with the semiconductor industry to realize universal quantum computers by 2050.

#### Milestone by 2030

We establish technology bases for fabricating multi-gubit devices toward development of large-scale quantum computers in cooperation with semiconductor industries. In parallel, we perform characterization and high-fidelity quantum operation of the multi-gubit devices. development of quantum channels suitable for connecting distant qubits,

and production of isotopically enriched silicon/silicongermanium (Si/SiGe) substrate. and in addition, demonstration of the principle of quantum error correction.



Figure 1 Qubit transfer channel.

### Milestone by 2025

We use high-quality substrate of Si/SiGe to establish fabrication technologies for implementing multi-gubit devices with a onedimensional gubit array as a fundamental structure, and use them to construct a prototype of small- to middle-scale quantum computers. In addition, we inspect new principles for quantum gate circuits constructed by electron wave packets as propagating qubits.





Figure 2 One-dimensional qubit array (left); Quantum gate circuit with electron wave packets as qubits (right).

#### Project structure

#### Seigo Tarucha, Project Manager (RIKEN)

Development of scalable fault-tolerant Si quantum bit devices Takashi Nakajima, RIKEN Takuji Miki, Kobe University

Development of middle-distance quantum link Takafumi Fujita, The University of Osaka

Development of isotopically controlled Si/SiGe substrate technology Satoru Mivamoto, AIST

Development of electron wave-packet qubits with new principle Michihisa Yamamoto, RIKEN, The University of Tokyo Shintaro Takada, The University of Osaka





Figure 3 Silicon qubit device and the device operation setup: control electronics (left) and a dilution refrigerator (right).

